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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kazutaka MIURA**

Group Art Unit: **2813**

Serial No.: **10/604,866**

Examiner: **Thanh T. NGUYEN**

Filed: **August 22, 2003**

Confirmation No.: **1865**

For: **METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE
UTILIZING ACTIVE OXYGEN (as amended herein)**

Attorney Docket No.: **030983**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

November 12, 2004

Sir:

This paper is filed in response to the Office Action dated July 12, 2004.

Amendments to the specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.